

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
**INFORMATION DISCLOSURE STATEMENT**

<b>APPLICANT:</b>	Takeshi Nogami, et al.	<b>ATTY DOCKET NO.:</b> 9792909-5802
<b>SERIAL NO.:</b>	not yet assigned	<b>GROUP ART UNIT:</b> not yet assigned
<b>DATE FILED:</b>	February 10, 2004	<b>EXAMINER:</b> not yet assigned
<b>INVENTION:</b>	"SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES"	

which is a Divisional of the following copending U.S. Application:

<b>APPLICANT:</b>	Takeshi Nogami, et al	<b>ATTY DOCKET NO.:</b> 9792909-5219
<b>SERIAL NO.:</b>	10/149858	<b>GROUP ART UNIT:</b> 2818
<b>DATE FILED:</b>	October 7, 2002	<b>EXAMINER:</b> R. Berry
<b>INVENTION:</b>	"SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES"	

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. **SUBMITTED UNITED STATES PATENT REFERENCES**

<b><u>Reference</u></b>	<b><u>Patent Number</u></b>	<b><u>Inventor</u></b>	<b><u>Issue Date</u></b>
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## II. SUBMITTED FOREIGN PATENT REFERENCES

<u>Reference</u>	<u>Patent Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	JP51 1326	Japan	January 8, 1976
AI	JP02 217498	Japan	August 30, 1990

## III. OTHER ITEMS OF INFORMATION

## IV. EXPLANATION OF RELEVANCE

The above references were made of record in parent application U.S. Serial No. 10/149,858 filed October 7, 2002, based on PCT application No. PCT/JP01/08981.

Submitted by,



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37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)						Docket No. 09792909-5802		Serial No.	
						Applicants: Takeshi Nogami, et al.			
						Filing Date February 10, 2004		Group Art Unit	
<b>U.S. PATENT DOCUMENTS</b>									
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate		
	AA								
	AB								
	AC								
	AD								
	AE								
	AF								
	AG								
<b>FOREIGN PATENT DOCUMENTS</b>									
		Document Number	Date	Country	Class	Subclass	Translation		
							Yes	No	
	AH	JP51 1326	1-8-76	Japan					
	AI	JP02 217498	8-30-90	Japan					
	AJ								
	AK								
	AL								
	AM								
	AN								
	AO								
	AP								
	AQ								
	AR								
	AS								
	AT								
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>									
	AU								
	AV								
	AW								
	AX								
	AY								
	AZ								
Examiner			Date Considered						
<b>*EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									